



Sheet 1 of 1

FORM PTO-1449 (SUBSTITUTE)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Attorney Docket No.: <b>Z&amp;PINFP10306</b>	Applic. No. <b>10/034,053</b>
	Applicant <b>Annette Snger</b>	
	Filing Date <b>December 20, 2001</b>	Group Art Unit <b>1763</b>

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
<i>Thm</i>	A	3,334,103	08/01/67	Feldman et al.	—	—	
	B	5,589,425	12/31/96	Hoshino et al.	—	—	
<i>Thm</i>	C	5,637,351	06/10/97	O'Neal et al.	—	—	
	D						
	E						
	F						
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	I						

## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
<i>Thm</i>	J	1 108 468 A1	08/20/01	Europe	—	—	X
<i>Thm</i>	K	1 158 070 A1	11/28/01	Europe	—	—	X
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>Thm</i>	O	J.G. Martin et al.: "Mechanisms of silicone dioxide deposition from the low pressure chemical vapor deposition of diethylsilane/oxygen mixtures", Journal of the Electrochemical Society, Vol. 142, November 1995, No. 11, pp. 3873-3880, INSPEC Abstract
	P	

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <b>9/16/03</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))Attorney Docket No.: Z&P-INFP10306  
Appl. No.

Applicant ANNETTE SAENGER

Filing Date December 20, 2001  
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<i>Thm</i>	A	5,637,351	6/10/97	O'Neal et al.			
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